Part of #2

If Appropriate

Form 1449*

INFORMATION DISCLOSURE STATEMENT
BY APPLICANT
(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

Serial No. Unknown

Group: Unknown:

U.S. PATENT DOCUMENTS

Name

Class

Subclass

FOREIGN PATENT DOCUMENTS Translation Yes No **Examiner Class Subclass Date Initial Document Number Country OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) **Examiner Annala, P., et al., "Electroplated Solder Alloys for Flip Chip Interconnections", Physica Scripta, T69, pp. 115-118, (1997) Datta, M., et al., "Electrochemical Fabrication of Mechanically Robust PbSn C4 Interconnections", Journal of the Electrochemical Society, 142 (11), (Nov. 1995) Honma, S., et al., "Effectiveness of Thin-film Barrier Metals for Eutectic Solder (Sept. 1997) -Bumps", Microelectronics International, 14 (3), pp. 47-50, Liu, C.Y., et al., "Electron microscopy study of interfacial reaction between eutectic SnPb and Cu/Ni(V)/Al thin film metallization", Journal of Applied Physics, 86 (11), pp. 1-5, (Dec. 1999)

Examiner	£~,	Kan	Date Considered	10/31/02

Initial

Document Number

Date